

Fig 1. A Schematic of metal-insulator-metal structure.

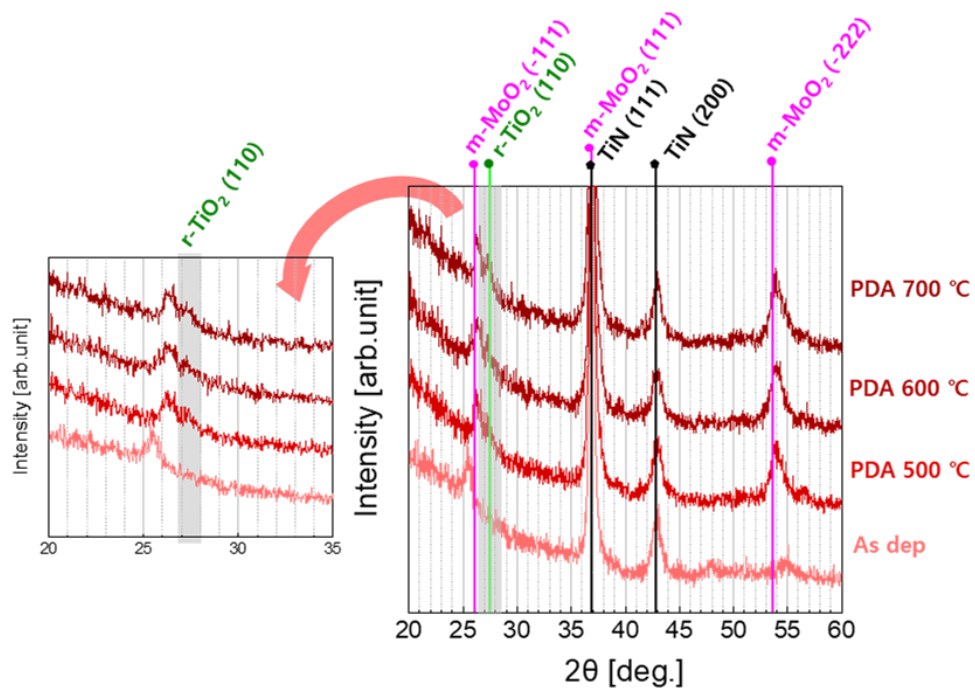


Fig 2. XRD patterns of the ALD TiO₂ films on as-deposited and annealed ALD MoO₂ films on TiN.